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Improvements in the X-ray characterisation of electroceramic thin films by the application of a novel combined analysis procedure

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OUTLINE

Introduction

Ferroelectric thin films and texture

Combined method of X-ray diffraction analysis

Results of the analysis of ferroelectric thin films with the combined method

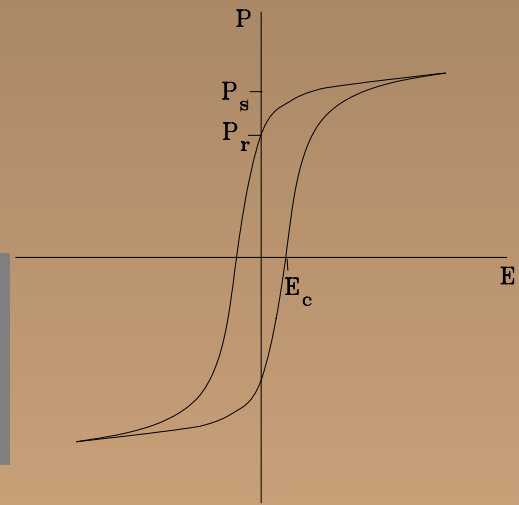
Separation of the contribution of different texture components.

Simultaneous texture and structure determination of substrate and film.

Conclusions

Improvement of performance by texture control in ferroelectric thin films

Ferroelectrics are polar dielectrics in which the direction of polarization can be re-oriented by application of an electric field.



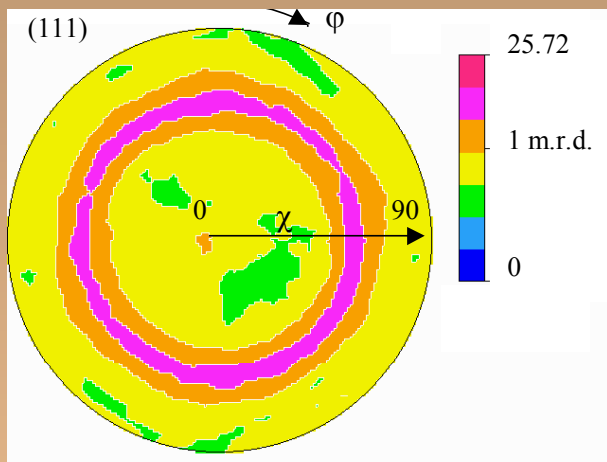
◆ The figures of merit that determine the **efficiency** of ferroelectric materials in technological applications (i.e. piezoelectric coefficient in MEMS) strongly depends on the **net polarization** of the material

The **polarization value** depends on several factors, among them: **TEXTURE**. **Preferential orientation along the polar axis produces an improved ferroelectric behaviour**

◆ In general, the **polycrystalline** ferroelectric materials need a **Poling process** with an intense electric field, in order to obtain any spontaneous polarization. **This is not needed in highly textured thin films along the polar axis**

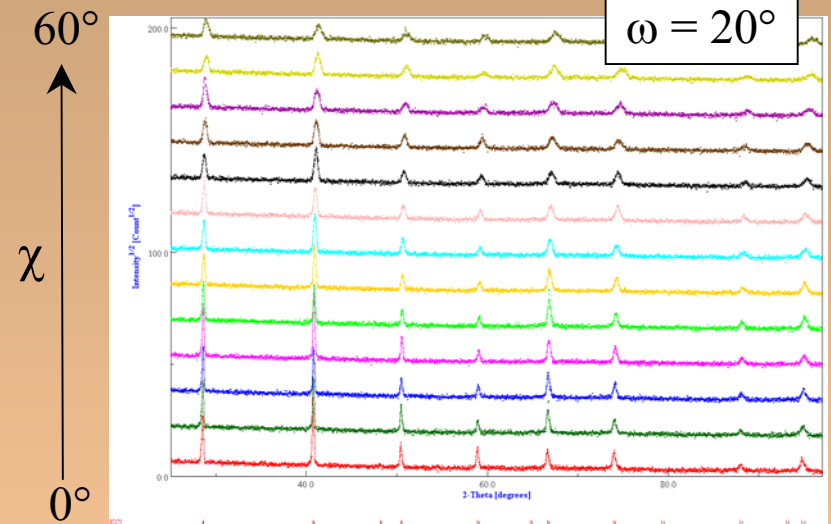
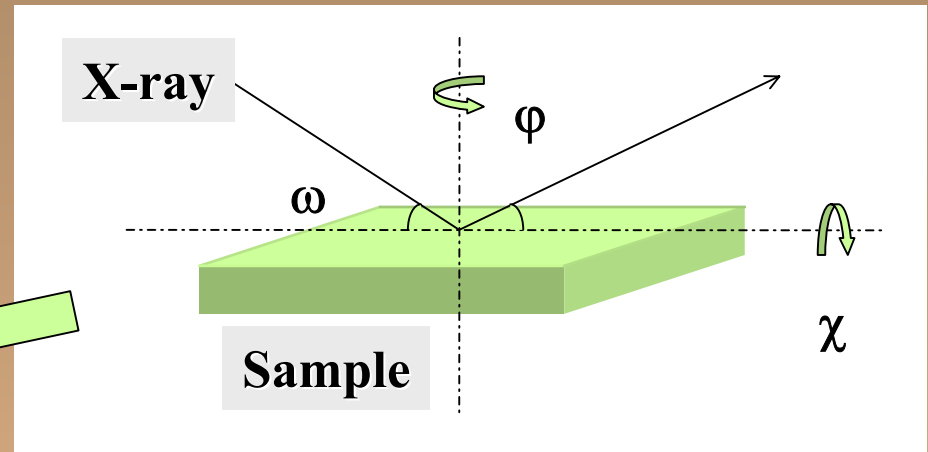
Generation of a pole figure

Pole figure



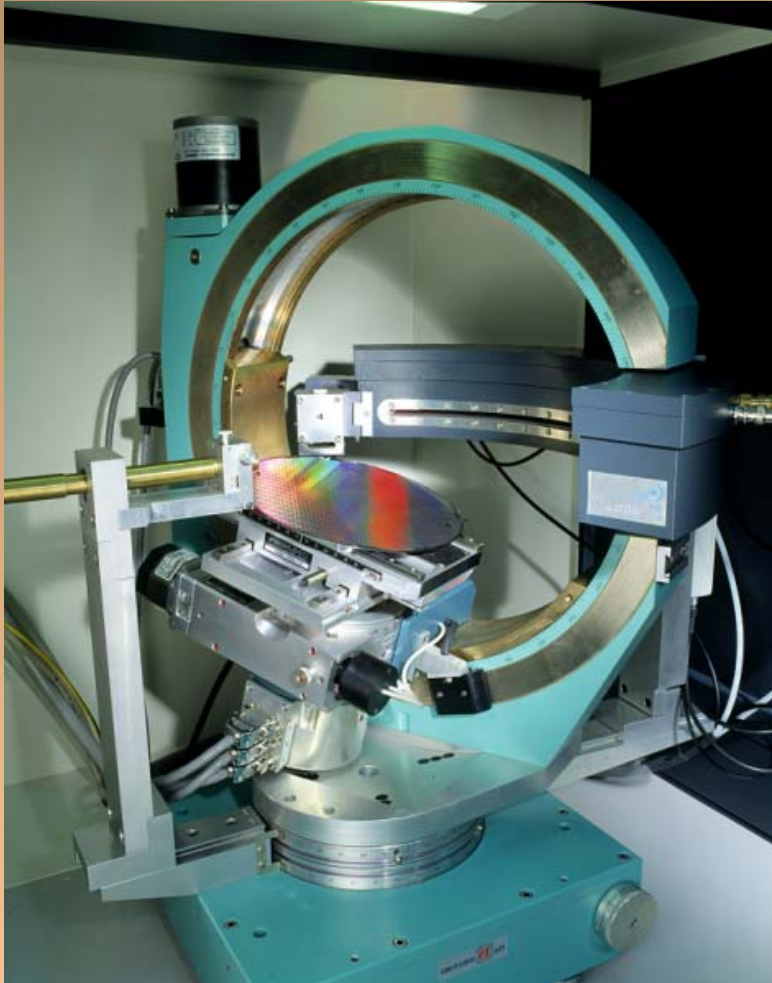
m.r.d. = multiple of a random distribution

(a sample without any preferred orientation shows pole figures with constant values of 1 m.r.d.)



Refinement of individual spectra

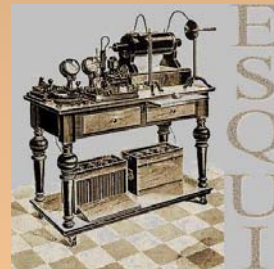
Equipment used for pole figure measurements



DIFFRACTOMETER EQUIPED WITH:

- Four-circle goniometer
- Curve position sensitive detector (PSD)

(MDM-Italy; developed in the ESQUI project)



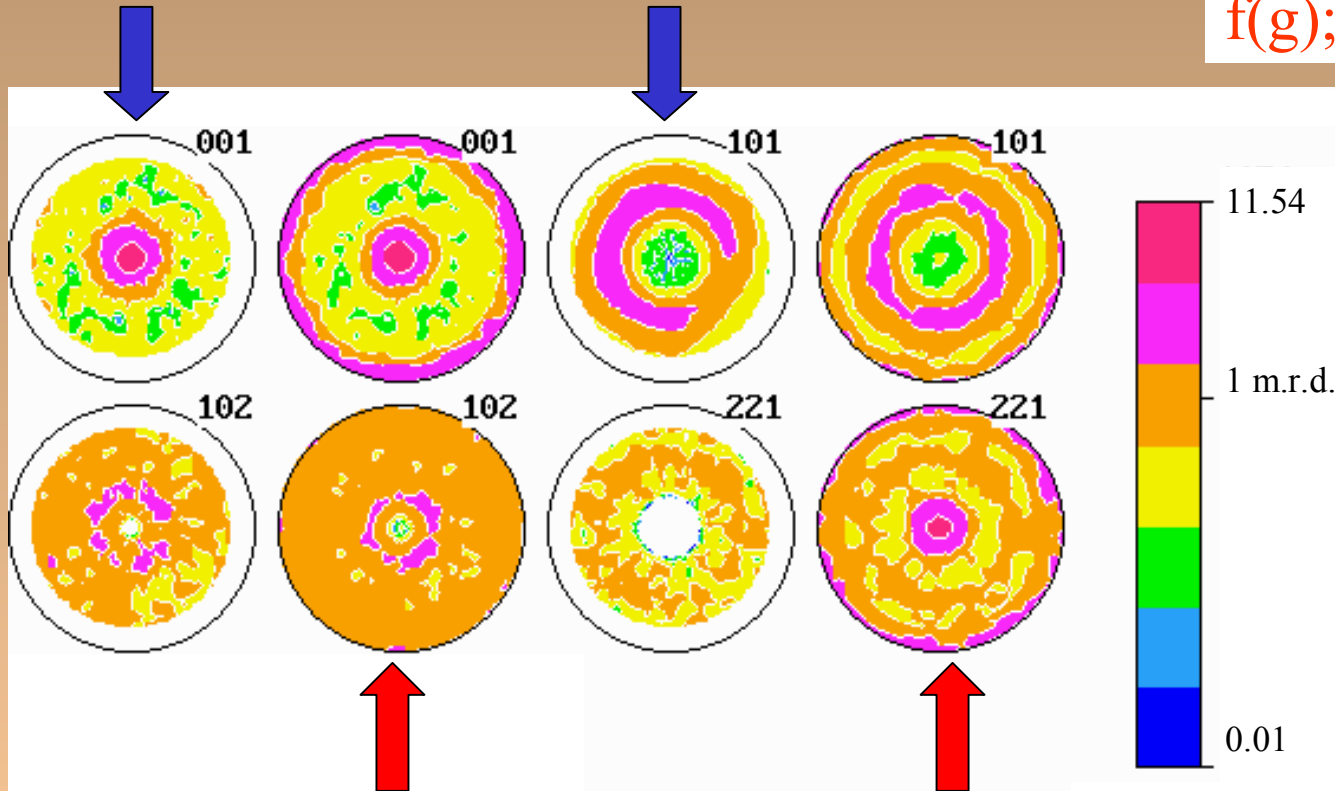
European-GROWTH project
“x-ray Expert System for
electronic films Quality
Improvement-ESQUI”

Advanced texture determination: Quantitative Texture Analysis

From the *experimental pole figures* we obtain by an iterative process an **ORIENTATION DISTRIBUTION FUNCTION (ODF)**

Experimental pole figures (incomplete)

$$f(g); g = \alpha, \beta, \gamma$$



Recalculated pole figures from ODF

Quantitative Texture Analysis

Orientation Distribution Function (ODF)



Texture Index (F^2)
(degree of orientation)

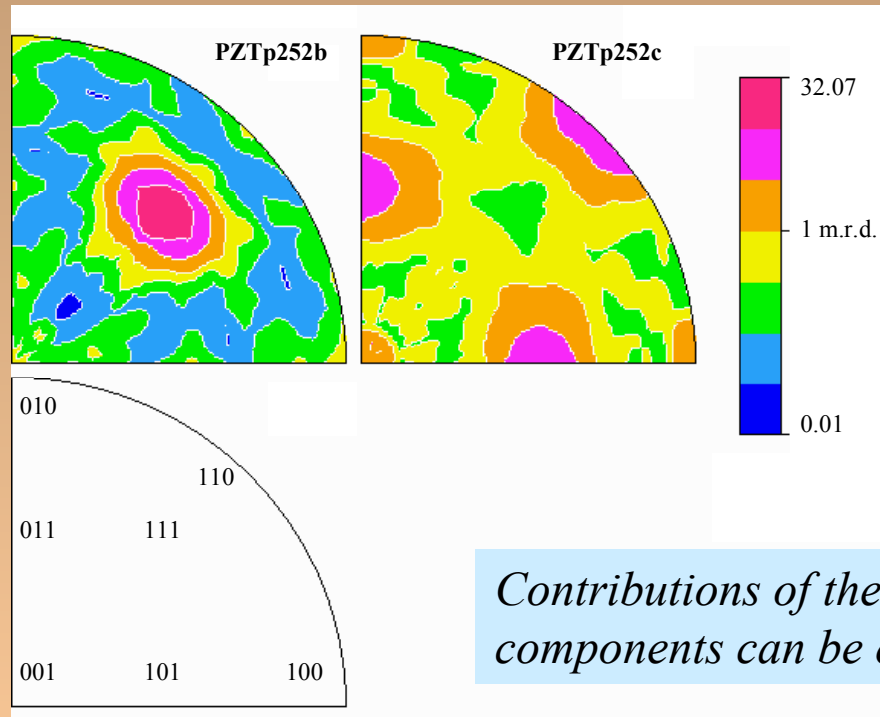
$$F^2 = \frac{1}{8\pi^2} \sum_i [f(g_i)]^2 \Delta g_i$$



Inverse pole figures
(texture components)

Inverse pole figure:

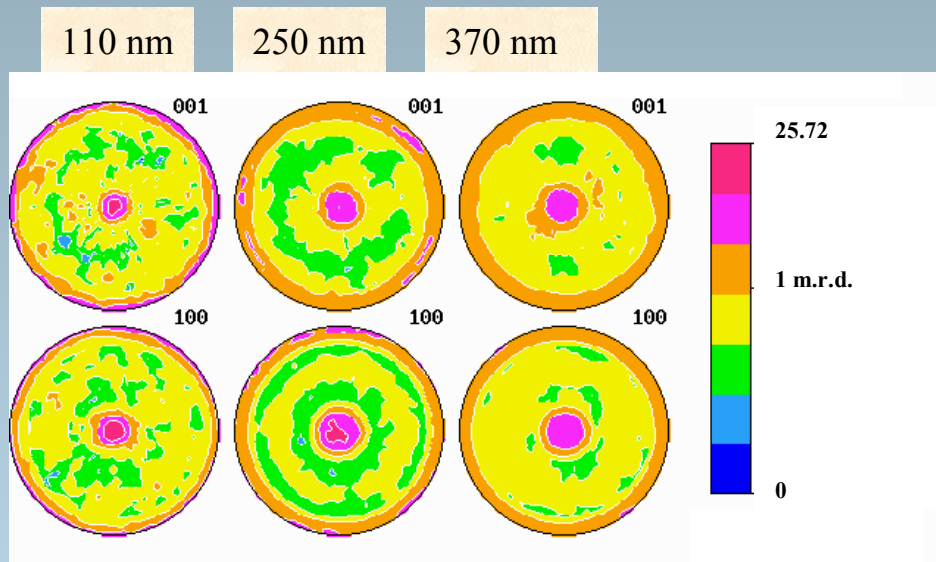
It describes the densities for crystal directions falling into the fixed sample direction y .



Contributions of the different components can be estimated

Quantitative Texture Analysis of polycrystalline ferroelectric thin films

Thickness dependence of texture

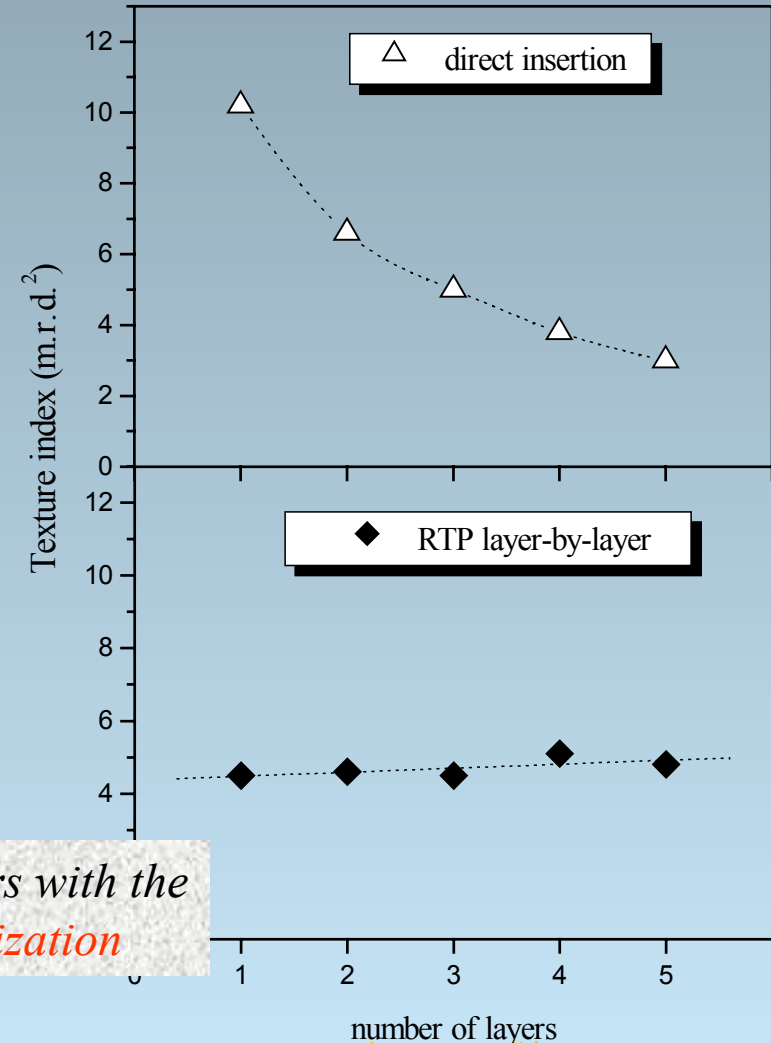


Similar contribution of the texture components
(mixed $\langle 001 \rangle$ and $\langle 100 \rangle$ orientation)

*Thickness effect disappears with the
layer-by-layer crystallization*

PTL on Pt/TiO₂/(100)Si

*PTL: Lanthanum modified lead titanate



Deduction of effective physical properties

$$S^c = \begin{pmatrix} 6.5 & -0.35 & -7.1 & 0 & 0 & 0 \\ -0.35 & 6.5 & -7.1 & 0 & 0 & 0 \\ -7.1 & -7.1 & 33.3 & 0 & 0 & 0 \\ 0 & 0 & 0 & 14.5 & 0 & 0 \\ 0 & 0 & 0 & 0 & 14.5 & 0 \\ 0 & 0 & 0 & 0 & 0 & 9.6 \end{pmatrix} \times 10^{-3} / GPa$$

Elastic properties of tetragonal PbTiO₃ single crystal

Kalinichev et al. J. Mater. Res. 12, 2623 (1997)

Geometric mean

$$S = \begin{pmatrix} 10.1 & -3.2 & -3.4 & 0 & 0 & 0 \\ -3.2 & 10.1 & -3.4 & 0 & 0 & 0 \\ -3.4 & -3.4 & 10.3 & 0 & 0 & 0 \\ 0 & 0 & 0 & 12.9 & 0 & 0 \\ 0 & 0 & 0 & 0 & 12.9 & 0 \\ 0 & 0 & 0 & 0 & 0 & 13.3 \end{pmatrix} \times 10^{-3} / GPa$$

$$S = \begin{pmatrix} 9.9 & -3.2 & -3.2 & 0 & 0 & 0 \\ -3.2 & 9.9 & -3.2 & 0 & 0 & 0 \\ -3.2 & -3.2 & 9.9 & 0 & 0 & 0 \\ 0 & 0 & 0 & 13.3 & 0 & 0 \\ 0 & 0 & 0 & 0 & 13.2 & 0 \\ 0 & 0 & 0 & 0 & 0 & 13.2 \end{pmatrix} \times 10^{-3} / GPa$$

PTL on Pt/TiO₂/(100)Si
Mixed $\langle 001 \rangle$, $\langle 100 \rangle$ orientation

PTL on Ti/Pt/Ti/(100)Si
Mixed $\langle 111 \rangle$ and $\langle 001 \rangle$, $\langle 100 \rangle$ orientation

*PTL: Lanthanum modified lead titanate

Further advances in X-ray characterisation: Combined analysis

INTEGRATED INTENSITIES

Iterative process WIMV

Orientation Distribution Function

*Rietveld
refinement*

LATTICE
PARAMETERS

*Stress
analysis*

RESIDUAL STRESS
Stress distribution function

Generally, labs perform a partial determination of these parameters

It allows a simultaneous and more precise determination of parameters

Software used is **MAUD**

General purpose program for diffraction spectra fitting developed by L.Lutterotti.
<http://www.ing.unitn.it/~luttero/maud/>



RESULTS OF THE APPLICATION OF THE COMBINED METHOD

Limitations of the simple Quantitative Texture Analysis (I)

We need to know the lattice parameters prior to the texture analysis

Ca modified lead titanates (PCT):

$$a = 3.8939 \text{ \AA}$$

$$c = 4.0496 \text{ \AA}$$

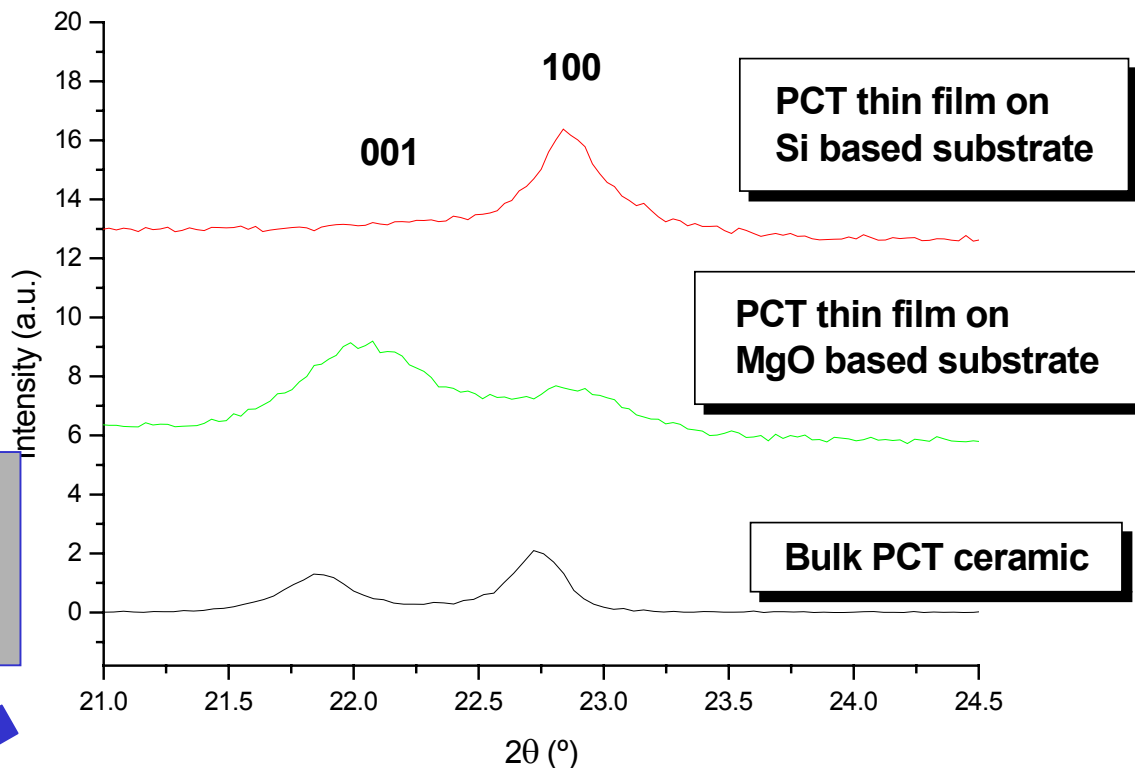
(bulk ceramic values
JCPDS 39-1336)

*Lattice parameters
are affected by
STRESS in thin films*

PCT thin films on
Pt/TiO₂/(100)Si:

$$a = ? \text{ \AA}$$

$$c = ? \text{ \AA}$$

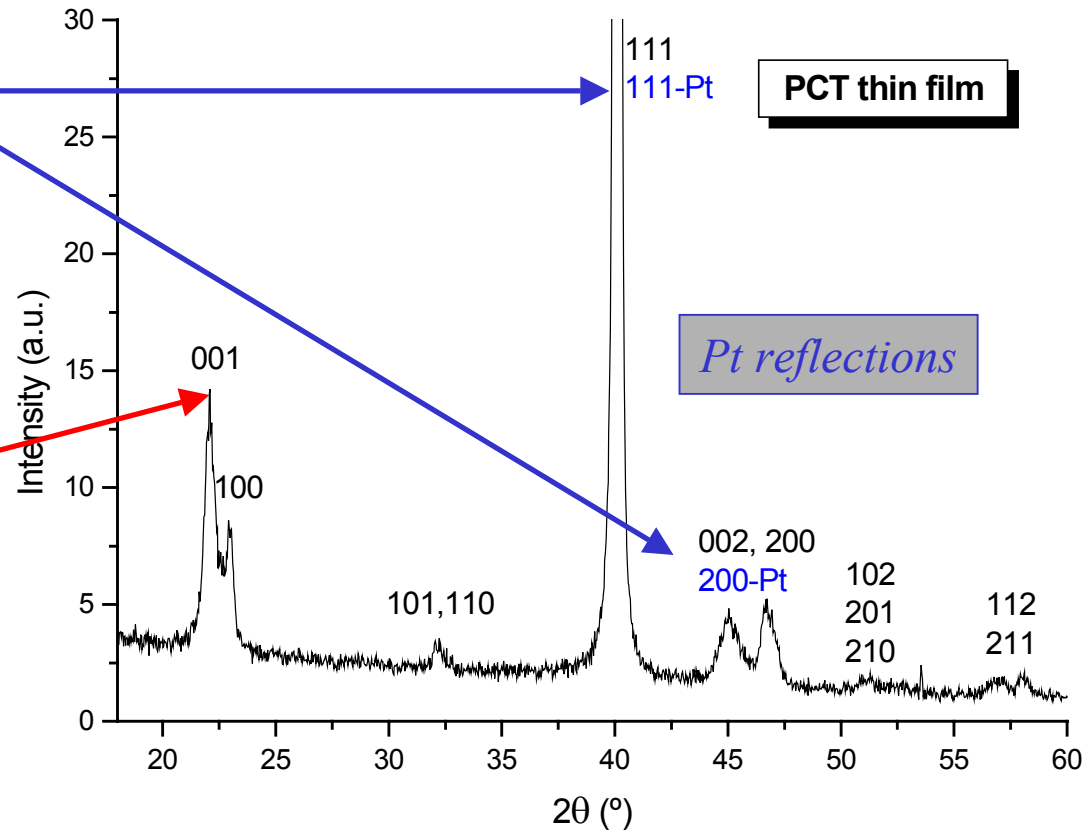


Limitations of the simple Quantitative Texture Analysis (II)

Structural parameters are difficult to obtain due to:

Substrate influence:
overlapping of reflections from the film and the substrate

TEXTURE effects:
peaks that do not appear at low χ angles

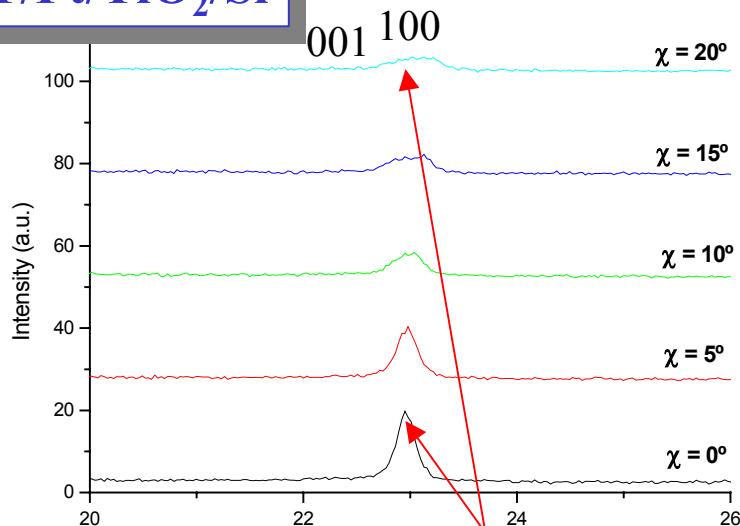


We need a simultaneous analysis of texture and structure of both film and substrate to solve completely the texture of the films

Separation of the contribution of texture contributions

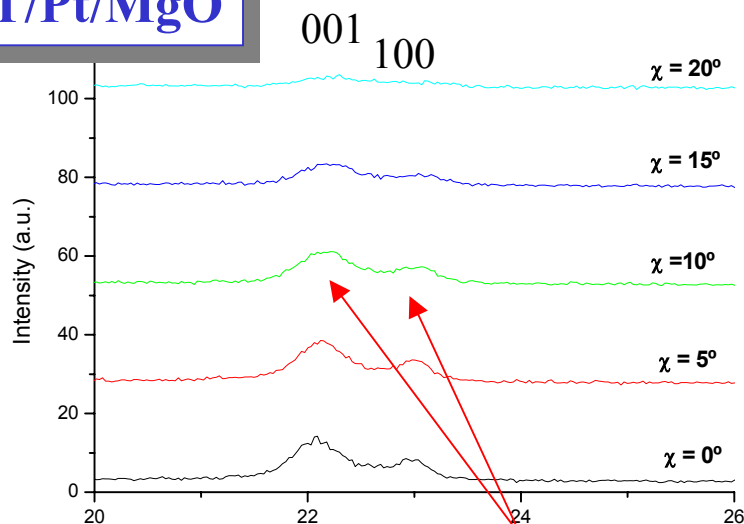
(simple Quantitative Texture Analysis)

PCT/Pt/TiO₂/Si



<100> orientation

PCT/Pt/MgO



<001> orientation

PCT film under tensile stress:

$\sigma = +1182$ Mpa

QTA results:

Estimated contribution
texture components.

<001> <100>

62%!! 38%!!

PCT film under compressive stress:

$\sigma = -700$ Mpa

QTA results:

Estimated contribution
texture components

<001> <100>

55%!! 45%!!

Separation of the contribution of texture contributions (Combined Method)

Instead of the integration of the overlapped peak (“**integral approach**”), and separating both contributions during the WIMV process, the combined method allows to deconvolute the peaks first, before the ODF calculation starts. As a result a more correct estimation of the contributions of $\langle 001 \rangle$ and $\langle 100 \rangle$ contributions is possible.

PCT/Pt/TiO₂/Si

$\sigma = +1182$ MPa

$c = 3.877$ Å

$a = 3.977$ Å

PCT/Pt/MgO

$\sigma = -700$ MPa

$c = 3.883$ Å

$a = 4.020$ Å

QTA results:

Estimated contrib.
 $\langle 001 \rangle$ $\langle 100 \rangle$

7%

93%

68%

32%

**Pyroelectric
Coefficient**
(10^{-8} C cm⁻² K⁻¹)

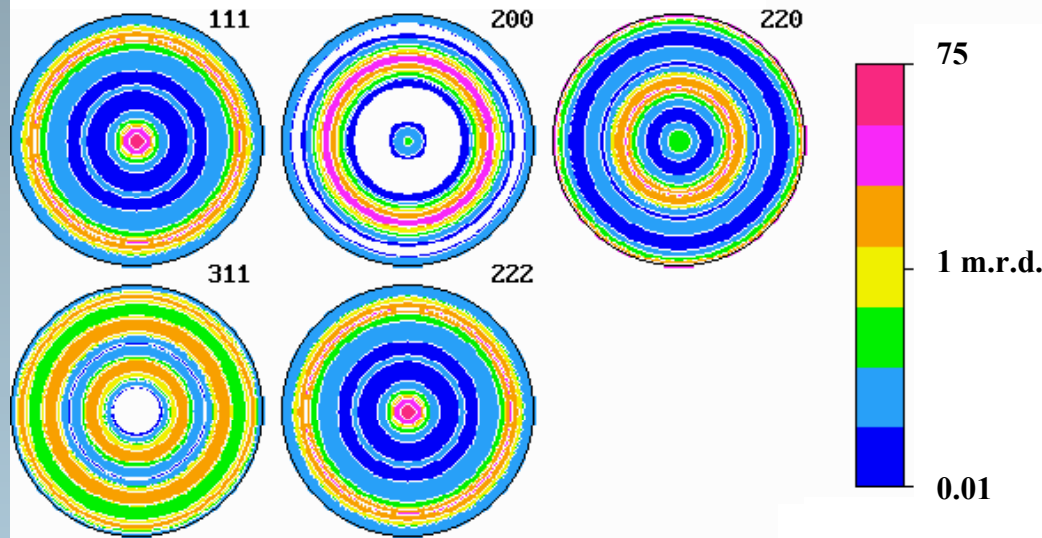
0.3

1.5

Simultaneously, we observe the effect of the applied stress on the lattice parameters

Simultaneous texture determination of substrate and film

(Combined Method)



Pt layer

$\langle 111 \rangle$ fibre orientation

New information on the Pt layer provided by the combined method

Texture index

F^2 (mrd²)

R factors (%)

non-treated substrate

Pt

129

$R_W=13, R_B=12$

annealed substrate

Pt

199

$R_W=8, R_B=14$

Pt (Recryst. 1h)

199

$R_W=9, R_B=20$

Pt (Recryst. 2h)

195

$R_W=9, R_B=14$

Pt (Recryst. 3h)

222

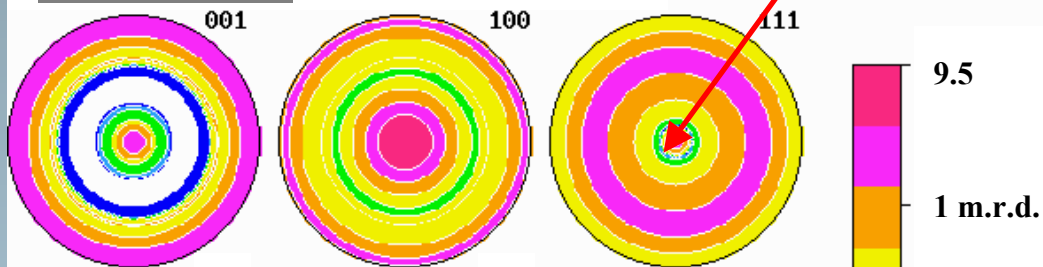
$R_W=27, R_B=12$

Annealing of the substrate, which involves crystal growth, results in an increase of the degree of orientation of the Pt layer.

Texture determination of film

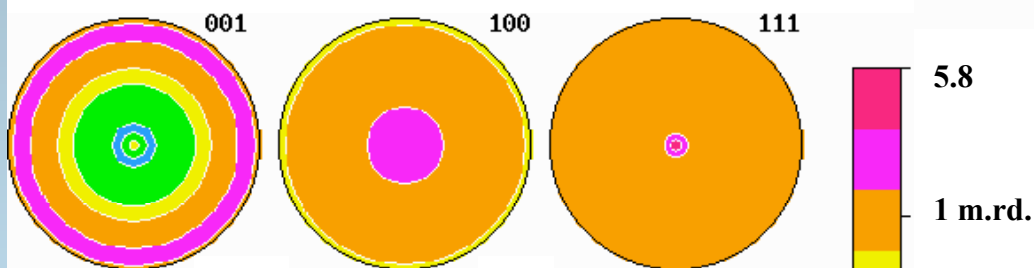
(Combined Method)

PCT film



PCT film on untreated substrate
Strong $\langle 100 \rangle$ orientation

Small $\langle 111 \rangle$ texture contribution
not observed by conventional QTA



PCT film on annealed substrate
Strong $\langle 111 \rangle$ orientation

	Texture index F^2 (mrd ²)
non-treated substrate	
PTC	5.2
annealed substrate	
PTC	2.1
PTC (Recryst. 1h)	2.1
PTC (Recryst. 2h)	2.5
PTC (Recryst. 3h)	2.5

Effect on the degree of orientation of the PCT film

New information on contribution of texture components provided by the combined method

Effect of the annealing of the substrate in the type of texture developed

CONCLUSIONS

The application of the combined method to ferroelectric calcium modified lead titanate thin films has proved to produce more accurate and reliable results than more traditional X-ray diffraction analysis approaches. It also provides **simultaneously information on the structure, microstructure and texture of both the deposited film and the substrate**, revealing important characteristics of the Pt layer used in this study as bottom electrode.

An important aspect covered is the **better resolution of the texture and, specifically of the contribution of the different texture components**, obtained by the combined method. We have shown two examples:

Separation of $\langle 001 \rangle$, $\langle 100 \rangle$ components

Reveal of small $\langle 111 \rangle$ texture component

see also:

J. Ricote and D. Chateigner J. Appl. Cryst. 37, 91-95 (2004)

J. Ricote et al. Thin Solid Films 450, 128-133 (2004)

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COST Action 528
Chemical Solution Deposition of Thin Films